

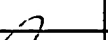
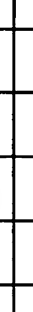




<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>	Docket Number (Optional) <b>KASA:019</b>	Application Number <b>NEW APPLICATION</b>
	Applicant(s) <b>Tatsutoshi SUZUKI</b>	
	Filing Date <b>December 19, 2001</b>	Group Art Unit

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
Z	US	5,921,855	7/99	Osterheld et al.	451	527	
Z	US	5,984,769	11/99	Bennett et al.	451	527	
Z	US	6,241,585	6/01	White	451	41	

JC978 U.S. PTO  
 10/026504  
 12/18/01

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	JP	11-70463	3/99	JAPAN (English Abst.)			✓	
	JP	47-16044	6/72	JAPAN (Concise Explanation)			✓	
	JP	63-22002	6/88	JAPAN (Concise Explanation)			✓	
	JP	2000-94303	4/00	JAPAN (English Abst.)			✓	

**OTHER DOCUMENTS** *(Including Author, Title, Date, Pertinent Pages, Etc.)*


EXAMINER <div style="text-align: center; font-size: 2em;">ZM</div>	DATE CONSIDERED <div style="text-align: center; font-size: 1.5em;">11/29/07</div>
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

**INFORMATION DISCLOSURE STATEMENT**  
(Use several sheets if necessary)

Docket Number (Optional)

KASA:0

Application Number

10/026,504

Applicant(s)

Tatsutoshi SUZUKI

Filing Date

December 19, 2001

Group Art Unit

3723

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

COPY OF PAPER  
ORIGINALLY FILED

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

		The Science of CMP; August 20, 1997; pages 113-119; Chapter 4, Part III "Structure and Feature of the polishing pad".

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.